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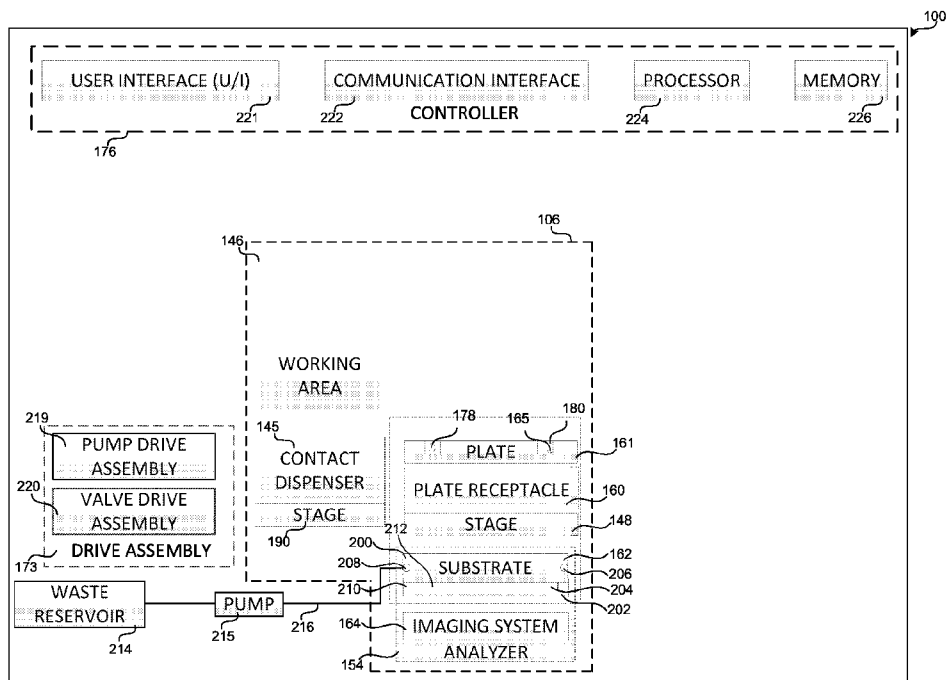


FIG. 1

(57) Abstract: Substrates for performing quantification processes and related systems and methods are disclosed. In an implementation, an apparatus includes a substrate and an imaging system. The substrate includes a pair of plates and a plurality of spacers positioned between the plates to define a gap between the pair of plates. A portion of a sample is to be received within the gap of the substrate and the imaging system is to obtain image data of the portion of the sample. The image data is to be used to determine a concentration of the portion of the sample.



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SUBSTRATES FOR PERFORMING QUANTIFICATION PROCESSES AND RELATED SYSTEMS AND METHODS

RELATED APPLICATION

[0001] This application claims the benefit of and priority to U.S. Provisional Patent Application Number 63/355,879, filed June 27, 2022, the content of which is incorporated by reference herein in its entirety and for all purposes.

Background

[0002] DNA libraries may be prepared to allow samples to be sequenced.

SUMMARY

[0003] Shortcomings of the prior art can be overcome and benefits as described later in this disclosure can be achieved through the provision of library preparation systems and methods. Various implementations of the apparatus and methods are described below, and the apparatus and methods, including and excluding the additional implementations enumerated below, in any combination (provided these combinations are not inconsistent), may overcome these shortcomings and achieve the benefits described herein.

[0004] In a first implementation, an apparatus includes a substrate and an imaging system. The substrate includes a pair of plates and a plurality of spacers positioned between the plates to define a gap between the pair of plates. A portion of a sample is to be received within the gap of the substrate and the imaging system is to obtain image data of the portion of the sample. The image data is to be used to determine a concentration of the portion of the sample.

[0005] In a second implementation, a method includes dispensing a sample onto a first plate of a substrate, positioning a second plate of the substrate on the first plate and defining a gap between the first plate and the second plate using a plurality of spacers, obtaining image data of the sample, and determining a concentration of the sample using the image data.

[0006] In a third implementation, a method includes dispensing a sample in an inlet of a channel of a substrate, obtaining image data of the sample, determining a concentration of the sample using the image data, and flowing the sample out of an outlet of the channel.

[0007] In a fourth implementation, an apparatus includes a substrate and an imaging system. The substrate includes a channel including an inlet and an outlet, and a valve. The outlet is in fluid communication with the channel. The valve is disposed between the inlet and the outlet. The channel includes a first portion between the valve and the inlet and a second portion between the valve and the outlet. A portion of a sample is to be received within

the first portion of the channel of the substrate and the imaging system is to obtain image data of the portion of the sample. The image data to be used to determine a concentration of the portion of the sample.

[0008] In a fifth implementation, an apparatus includes a substrate including a channel including an inlet and an inlet, and a valve disposed between the inlet and the outlet. The channel includes a first portion between the valve and the inlet and a second portion between the valve the outlet. A portion of a sample is to be received within the first portion of the channel of the substrate and an imaging system is to obtain image data of the portion of the sample. The image data to be used to determine a concentration of the portion of the sample.

[0009] In a sixth implementation, an apparatus includes a circular substrate including a plurality of channels. Each channel includes an inlet, an outlet, and a valve disposed between the inlet and the outlet. The channel includes a first portion between the valve and the inlet and a second portion between the valve the outlet.

[0010] In a seventh implementation, a method includes rotating a substrate around an axis of rotation at a first rate to draw a portion of a sample into a first portion of a channel of the substrate. The substrate includes the channel, an inlet, an outlet in fluid communication with the channel, and a valve disposed between the inlet and the outlet. The channel includes the first portion between the valve and the inlet and a second portion between the valve and the outlet. The method includes stopping the rotation of the substrate and obtaining image data of the portion of the sample. The image data to be used to determine a concentration of the portion of the sample. The method includes rotating the substrate around the axis of rotation at a second rate to urge the portion of the sample through the valve and into the second portion of the channel of the substrate and out of the outlet.

[0011] In an eighth implementation, a method includes rotating a substrate around an axis of rotation to draw a portion of a sample into a first portion of a channel of the substrate. The substrate including the channel, an inlet, an outlet in fluid communication with the channel, and a valve disposed between the inlet and the outlet. The channel includes the first portion between the valve and the inlet and a second portion between the valve and the outlet. The method includes stopping the rotation of the substrate and obtaining image data of the portion of the sample. The image data to be used to determine a concentration of the portion of the sample. The method includes actuating the valve to an open position and rotating the substrate around the axis of rotation to urge the portion of the sample through the valve and into the second portion of the channel of the substrate and out of the outlet.

- [0012]** In further accordance with the foregoing the first, second, third, fourth, fifth, sixth, seventh, and/or eighth implementations, an apparatus and/or method may further include or comprise any one or more of the following:
- [0013]** In an implementation, the spacers include ball bearings having opposing flat surfaces.
- [0014]** In another implementation, the plurality of spacers include three spacers.
- [0015]** In another implementation, the gap is about 500 micrometers.
- [0016]** In another implementation, the apparatus includes a channel that is defined between the pair of plates.
- [0017]** In another implementation, the substrate further includes a seal positioned between the pair of plates and defines the channel.
- [0018]** In another implementation, the seal is positioned around a perimeter of the pair of plates.
- [0019]** In another implementation, the substrate includes a mask.
- [0020]** In another implementation, the mask is an opaque mask.
- [0021]** In another implementation, the substrate includes an inlet and an outlet in fluid communication with the gap.
- [0022]** In another implementation, the substrate includes a plurality of channels.
- [0023]** In another implementation, the substrate includes a first inlet, a second inlet, a third inlet, and an outlet in fluid communication with the gap.
- [0024]** In another implementation, the spacers include ball bearings having opposing flat surfaces.
- [0025]** In another implementation, the plurality of spacers includes three spacers.
- [0026]** In another implementation, the method also includes positioning a seal around a perimeter of the first plate and the second plate.
- [0027]** In another implementation, obtaining the image data includes obtaining the image data through a window of the substrate.
- [0028]** In another implementation, the window includes an unmasked region and a masked region may surround the unmasked region.

- [0029]** In another implementation, the method includes dispensing a fluid into the channel to separate the sample and another sample.
- [0030]** In another implementation, the fluid includes oil.
- [0031]** In another implementation, dispensing the fluid into the channel includes dispensing the fluid into a second inlet of the channel.
- [0032]** In another implementation, the apparatus includes a pump to move the sample from the inlet to the outlet.
- [0033]** In another implementation, the pump comprises a plate comprising an axis of rotation and an actuator to rotate the plate, the substrate coupled to the plate and extending radially from the axis of rotation.
- [0034]** In another implementation, the apparatus includes a second substrate coupled to the plate and extending radially from the axis of rotation.
- [0035]** In another implementation, the plate includes a first position and a second position. The substrate is positioned at the first position and the second substrate positioned at the second position. The first position opposite the second position.
- [0036]** In another implementation, the second substrate is a mirror image of the substrate on the plate.
- [0037]** In another implementation, the pump includes an optical access area.
- [0038]** In another implementation, the apparatus includes a waste reservoir fluidly coupled to the outlet.
- [0039]** In another implementation, the waste reservoir includes a vent.
- [0040]** In another implementation, the vent includes a porous frit.
- [0041]** In another implementation, the waste reservoir includes a disposable microfluidic card assembly.
- [0042]** In another implementation, the valve includes a virtual valve.
- [0043]** In another implementation, the virtual valve includes a constriction.
- [0044]** In another implementation, the portion of the sample is to flow from the first portion, through the valve, the second portion, and the outlet after the image data of the portion of the sample is obtained.
- [0045]** In another implementation, the valve includes a virtual valve.
- [0046]** In another implementation, the virtual valve includes a constriction.

- [0047]** In another implementation, the first portion of the channel has a first width, the second portion of the channel has a second width, and the virtual valve has a third width, the third width less than the first width and the second width.
- [0048]** In another implementation, the channel has a height of between about 200 micrometers and about 500 micrometers.
- [0049]** In another implementation, the substrate includes a mask.
- [0050]** In another implementation, the mask is an opaque mask.
- [0051]** In another implementation, the substrate includes a microfluidic card.
- [0052]** In another implementation, the valve includes an elastomer valve or a rotary face-sealing valve.
- [0053]** In another implementation, the apparatus includes an inlet port at the inlet that is to funnel the portion of the sample into the channel.
- [0054]** In another implementation, the inlet port includes a flow passage including a frustrum-shaped flow passage.
- [0055]** In another implementation, the inlet port includes a first surface and a second surface. The first surface is coupled to the substrate. The frustrum-shaped flow passage includes a base opening at the first surface and a top opening at the second surface. The base opening having a perimeter. The inlet being tangential to the base opening.
- [0056]** In another implementation, the circular substrate includes a plastic disc.
- [0057]** In another implementation, the circular substrate includes a circular wafer.
- [0058]** In another implementation, the circular substrate includes an axis of rotation. The apparatus includes an actuator to rotate the circular substrate about the axis of rotation.
- [0059]** In another implementation, the method includes receiving the portion of the sample in a waste reservoir fluidly coupled to the outlet.
- [0060]** In another implementation, the method includes rinsing the channel by flowing a rinse fluid through the channel and between the inlet and the outlet.
- [0061]** In another implementation, the valve is a virtual valve.
- [0062]** In another implementation, the virtual valve includes a constriction.
- [0063]** In another implementation, the method includes rinsing the channel by flowing a rinse fluid through the channel and between the inlet and the outlet.

[0064] It should be appreciated that all combinations of the foregoing concepts and additional concepts discussed in greater detail below (provided such concepts are not mutually inconsistent) are contemplated as being part of the subject matter disclosed herein and/or may be combined to achieve the particular benefits of a particular aspect described herein. In particular, all combinations of claimed subject matter appearing at the end of this disclosure are contemplated as being part of the subject matter disclosed herein.

BRIEF DESCRIPTION OF THE DRAWINGS

[0065] FIG. 1 illustrates a schematic diagram of an implementation of a system in accordance with the teachings of this disclosure.

[0066] FIG. 2 is a top isometric view of an implementation of a substrate that can be used to implement the substrate of FIG. 1.

[0067] FIG. 3 is a cross-sectional view of the substrate of FIG. 2.

[0068] FIG. 4 is a cross-sectional view of the substrate of FIG. 2 showing the first plate removed from the second plate and the contact dispenser dispensing the portions onto the second plate.

[0069] FIG. 5 is a cross-sectional view of the substrate of FIG. 2 showing the first plate positioned over top of the second plate and the imaging system obtaining image data of one of the portions.

[0070] FIG. 6 is a top isometric view of an implementation of a substrate that can be used to implement the substrate of FIG. 1.

[0071] FIG. 7 is a cross-sectional view of the substrate of FIG. 6 showing the first plate positioned over top of the second plate and the imaging system obtaining image data of the portion.

[0072] FIG. 8 is a cross-sectional view of an implementation of a substrate that can be used to implement the substrate of FIG. 1.

[0073] FIG. 9 is a top isometric view of an implementation of a substrate that can be used to implement the substrate of FIG. 1.

[0074] FIG. 10 is a cross-sectional view of the substrate of FIG. 9 showing the first plate positioned over top of the second plate and the imaging system obtaining image data of the portion aligned with the window of the substrate.

[0075] FIG. 11 illustrates a flowchart describing a process for using the substrates and the imaging system of FIGS. 1 – 10 or any of the other implementations disclosed herein.

[0076] FIG. 12 illustrates another flowchart describing a process for using the substrates and the imaging system of FIGS. 1 – 10 or any of the other implementations disclosed herein.

[0077] FIG. 13 is a schematic implementation of a substrate and the imaging system that can be used to implement the substrate and the imaging system of FIG. 1.

[0078] FIG. 14 is a top view of the substrate and the pump of FIG. 13.

[0079] FIG. 15 is a detailed view of a portion of the substrate and the pump of FIG. 13.

[0080] FIG. 16 is a schematic implementation of a circular substrate that can be used to implement the substrate and the pump of FIG. 1.

[0081] FIG. 17 illustrates a flowchart for a method of implementing the examples disclosed herein.

[0082] FIG. 18 illustrates another flowchart for a method of implementing the examples disclosed herein.

DETAILED DESCRIPTION

[0083] Although the following text discloses a detailed description of implementations of methods, apparatuses and/or articles of manufacture, it should be understood that the legal scope of the property right is defined by the words of the claims set forth at the end of this patent. Accordingly, the following detailed description is to be construed as examples only and does not describe every possible implementation, as describing every possible implementation would be impractical, if not impossible. Numerous alternative implementations could be implemented, using either current technology or technology developed after the filing date of this patent. It is envisioned that such alternative implementations would still fall within the scope of the claims.

[0084] FIG. 1 illustrates a schematic diagram of an implementation of a system 100 in accordance with the teachings of this disclosure. The system 100 can be used to automatically, easily, and efficiently perform quantification processes used when preparing DNA libraries for sequencing applications, for example. The system 100 includes a working area 106 in the implementation shown. The working area 106 includes a contact dispenser 145, a stage 148, and an analyzer area 154 in the implementation shown. The stage 148 may be an x-y stage.

[0085] The stage 148 has a plate receptacle 160 that receives a plate 161 and the analyzer area 154 includes a substrate 162 and an imaging system 164. The plate

receptacle 160 may be referred to as a plate station. The imaging system 164 may be a fluorescent imaging system, a fluorescence spectrophotometer including an objective lens, and/or a solid-state imaging device. The solid-state imaging device may include a charge coupled device (CCD) and/or a complementary metal oxide semiconductor (CMOS).

[0086] The system 100 also includes a drive assembly 173 and a controller 176. The plate 161 may contain different samples 165. The samples 165 may be a biological sample derived from a human, animal, plant, bacteria, or fungi. Other sources of obtaining the biological samples may prove suitable. A stage 190 may be coupled to and used to move the contact dispenser 145. The stage 190 may be a z-stage. The stage 190 may alternatively be omitted.

[0087] The analyzer area 154 of the system 100 can be used to perform quantification processes. The substrate 162 of the analyzer area 154 is carried by the stage 148 in the implementation shown, and the imaging system 164 is spaced from the stage 148 and coupled to a portion of the system 100 such as a frame of the system 100. The imaging system 164 may alternatively be carried by the stage 148. The substrate 162 is shown including a pair of plates 200, 202 between which a gap 204 is defined. The plate 200 may be referred to as the first plate or alternatively as the second plate and the plate 202 may be referred to as the second plate or alternatively as the first plate. The substrate 162 also has an inlet 206 and an outlet 208 in fluid communication with the gap 204 and a seal 210 positioned between the pair of plates 200, 202. The plates 202, 202 and the seal 210 define a channel 212 between the inlet 206 and the outlet 208. A waste reservoir 214 is fluidly coupled to the outlet 208 of the substrate 162 by a fluidic line 216. A pump 215 may be fluidly coupled between the outlet of the substrate 162 and the waste reservoir 214. The pump 215 may be implemented by a syringe pump, a peristaltic pump, and/or a diaphragm pump. Other types of fluid transfer devices may be used, however.

[0088] The stage 148 aligns the contact dispenser 145 with the plate 161 to perform the quantification processes and the contact dispenser 145 aspirates a portion of a reagent 178 and the sample 165 from a well 180 of the plate 161. The portion of the reagent 178 and the sample 165 may be about 2 μ L.

[0089] The stage 148 aligns the contact dispenser 145 with the inlet 206 of the substrate 162 and the contact dispenser 145 dispenses the portion of the reagent 178 and the sample 165 into the inlet 206 of the substrate 162. The portion of the reagent 178 and the sample 165 may flow and/or be positioned between the inlet 206 and the outlet 208 in this implementation and the imaging system 164 obtains image data of the portion of the reagent 178 and the sample 165. The imaging system 164 and/or the system 100 uses the

image data to determine a concentration of the sample 165. Negative pressure, oil, and/or another substance may be used to urge the portion of the reagent 178 and the sample 165 between the inlet 206 and the outlet 208. The first plate 200 may alternatively be hingably coupled or removably coupled to the second plate 202 to allow the contact dispenser 145 to dispense the portion of the reagent 178 and the sample 165 onto the second plate 202 prior to the first plate 200 being positioned ovetop of the second plate 202 (see, FIG. 4, for example).

[0090] The drive assembly 173 includes a pump drive assembly 219 and a valve drive assembly 220. The controller 176 includes a user interface 221, a communication interface 222, one or more processors 224, and a memory 226 storing instructions executable by the one or more processors 224 to perform various functions including the disclosed implementations. The user interface 221, the communication interface 222, and the memory 226 are electrically and/or communicatively coupled to the one or more processors 224.

[0091] In an implementation, the user interface 221 receives input from a user and provides information to the user associated with the operation of the system 100 and/or an analysis taking place. The user interface 221 may include a touch screen, a display, a key board, a speaker(s), a mouse, a track ball, and/or a voice recognition system. The touch screen and/or the display may display a graphical user interface (GUI).

[0092] In an implementation, the communication interface 222 enables communication between the system 100 and a remote system(s) (e.g., computers) using a network(s). The network(s) may include an intranet, a local-area network (LAN), a wide-area network (WAN), the intranet, etc. Some of the communications provided to the remote system may be associated with quantification process(es) generated or otherwise obtained by the system 100. Some of the communications provided to the system 100 may be associated with an amplification process(es), a cleanup process(es), a library normalization process(es), and/or a pooling process(es) to be executed by the system 100.

[0093] The one or more processors 224 and/or the system 100 may include one or more of a processor-based system(s) or a microprocessor-based system(s). In some implementations, the one or more processors 224 and/or the system 100 includes a reduced-instruction set computer(s) (RISC), an application specific integrated circuit(s) (ASICs), a field programable gate array(s) (FPGAs), a field programable logic device(s) (FPLD(s)), a logic circuit(s), and/or another logic-based device executing various functions including the ones described herein.

[0094] The memory 226 can include one or more of a hard disk drive, a flash memory, a read-only memory (ROM), erasable programmable read-only memory (EPROM), electrically erasable programmable read-only memory (EEPROM), a random-access memory (RAM), non-volatile RAM (NVRAM) memory, a compact disk (CD), a digital versatile disk (DVD), a cache, and/or any other storage device or storage disk in which information is stored for any duration (e.g., permanently, temporarily, for extended periods of time, for buffering, for caching).

[0095] FIG. 2 is a top isometric view of an implementation of a substrate 400 that can be used to implement the substrate 162 of FIG. 1. The substrate 400 includes the pair of plates 200, 202 and spacers 402 positioned between the plates 200, 202 to define the gap 204 between the plates 200, 202. The spacers 402 are ball bearings 404 having opposing flat surfaces 406, 408. The substrate 400 may include three ball bearings 404 to define the gap 204 between the plates 200, 202 to be about 500 μm . As set forth herein, the phrase “about 500 μm ” means $\pm 5 \mu\text{m}$ of 500 μm including 500 μm itself and/or accounts for manufacturing tolerances.

[0096] Portions 410 of the sample 165 and the reagent 178 are shown positioned between the plates 200, 202. The portions 410 may be referred to as droplets. Each of the portions 410 may relate to a different sample 165. The portions 410 may be approximately 2 μL each and have a nominal diameter of about 2 mm.

[0097] FIG. 3 is a cross-sectional view of the substrate 400 of FIG. 2. The substrate 400 shows a channel 412 defined between the plates 200, 202 and a seal 414 positioned between the plates 200, 202 that defines the channel 412. The plates 200, 202 also define the channel 412. The seal 414 may be a compliant gasket seal. The channel 412 of the substrate 400 can be flushed and/or cleaned using a liquid such as ethanol and purged with air after the quantification processes are complete. The portions 410 of the sample 165 and the reagent 178 can be flowed to the waste reservoir 214, for example.

[0098] FIG. 4 is a cross-sectional view of the substrate 400 of FIG. 2 showing the first plate 200 removed from the second plate 202 and the contact dispenser 145 dispensing the portions 410 onto the second plate 202.

[0099] FIG. 5 is a cross-sectional view of the substrate 400 of FIG. 2 showing the first plate 200 positioned over top of the second plate 202 and the imaging system 164 obtaining image data of one of the portions 410. The imaging system 164 and/or the system 100 may use the image data to determine an intensity value and a diameter of the portion 410. The imaging system 164 and/or the system 100 can thereafter compute a concentration of the portion 410 using a total florescent measurement, for example.

[00100] The imaging system 164 can also or alternatively be used to perform a calibration process where the imaging system 164 obtains image data of the portion 410 and the imaging system 164 and/or the system 100 calibrates the contact dispenser 145 by determining a volume of the portion 410, comparing the determined volume of the portion 410 to a reference volume, and determining a difference between the determined volume and the reference volume. The system 100 can calibrate and/or change an amount of liquid dispensed by the contact dispenser 145 if the difference between the determined volume and the reference volume is greater than a threshold.

[00101] FIG. 6 is a top isometric view of an implementation of a substrate 500 that can be used to implement the substrate 162 of FIG. 1. The substrate 500 of FIG. 6 is similar to the substrate 400 of FIG. 2. The substrate 500 of FIG. 6 includes a mask 502 however that is an opaque mask 504 in the implementation shown. The mask 502 defines a window 506 that allows the imaging system 164 to obtain image data of a portion 510 of the sample 165 and the reagent 178. The portion 510 may be a 2 μ L droplet. The window 506 may be referred to as an unmasked region. An area 508 of the mask 502 may be relatively well defined and is shown surrounding the window 506. The imaging system 164 may alternatively be used to measure the area 508 of the mask 502. The imaging system 164 may be able to measure the area 508 of the mask 502 within about 5% accuracy. The accuracy of measurement by the imaging system 164 may be different, however.

[00102] The substrate 500 may include the spacers to accurately define the gap 204 between the plates 200, 202. The gap 204 may be between about 200 μ m and about 500 μ m. The imaging system 164 may alternatively be used to measure the gap 204. The imaging system 164 may be able to measure the gap 204 within about 1% accuracy. The imaging system 164 may be able to determine a liquid volume of the portion 510 within about 7% accuracy.

[00103] FIG. 7 is a cross-sectional view of the substrate 500 of FIG. 6 showing the first plate 200 positioned over top of the second plate 202 and the imaging system 164 obtaining image data of the portion 510. The imaging system 164 and/or the system 100 may use the image data to determine an intensity value of the portion 510 viewable through the window 506. The imaging system 164 and/or the system 100 can use the intensity value and a thickness 512 of the gap 204 to determine a concentration of the portion 510. The channel 412 of the substrate 500 can be flushed and/or cleaned using a liquid such as ethanol and purged with air after the quantification processes are complete.

[00104] FIG. 8 is a cross-sectional view of an implementation of a substrate 600 that can be used to implement the substrate 162 of FIG. 1. The substrate 600 of FIG. 8 is similar

to the substrate 500 of FIG. 7. The substrate 600 of FIG. 8 includes a divider 602 however that is coupled between the plates 200, 202 and defines a first channel 604 and a second channel 606. Put another way, the substrate 600 has a plurality of channels 604, 606. Each of the channels 604, 606 can have a corresponding inlet 206 and/or a corresponding outlet 208. Each channel 604, 606 can thus receive a different sample and multiple samples can be processed and/or flowed through the substrate 600 at the same or similar times. While the substrate 600 is shown having two channels 604, 606, the substrate 600 can have any number of channels 604, 606.

[00105] FIG. 9 is a top isometric view of an implementation of a substrate 700 that can be used to implement the substrate 162 of FIG. 1. The substrate 700 of FIG. 9 is similar to the substrate 500 of FIG. 6. The substrate 700 of FIG. 9 includes a first inlet 702, a second inlet 703, a third inlet 704, and the outlet 208 in fluid communication with the gap 204. Portions 705 of the sample 165 and the reagent 178 are shown separated by another fluid 706. The portions 705 may be referred to as droplets. The fluid 706 may be oil. The contact dispenser 145 deposits the portions 705 in the second inlet 703 in operation and the fluid 706 is dispensed into the first inlet 702 and/or the third inlet 704. The fluid 706 separates the portions 705. The channel 412 may be under negative pressure and the negative pressure may sequentially urge the portions 705 between the second inlet 703 and the outlet 208. The fluid 706 may also or alternatively be used to urge the portions 705 between the second inlet 703 and the outlet 208.

[00106] FIG. 10 is a cross-sectional view of the substrate 700 of FIG. 9 showing the first plate 200 positioned over top of the second plate 202 and the imaging system 164 obtaining image data of the portion 705 aligned with the window 506 of the substrate 700. The imaging system 164 obtains image data of each of the portions 705 as the corresponding portions are aligned with the window 506. The imaging system 164 and/or the system 100 may use the image data to determine an intensity value of the portion 510 viewable through the window 506. The imaging system 164 and/or the system 100 can use the intensity value and the thickness 512 of the gap 204 to determine a concentration of the portion 510. The channel 412 of the substrate 500 can be flushed and/or cleaned using the fluid 706 and/or using a liquid such as ethanol after the quantification processes are complete. The channel 412 of the substrate 700 may be dried by purging the substrate 700 with air.

[00107] FIGS. 11 and 12 illustrate flowcharts describing a process for using the substrates 162, 400, 500, 600, 700 and the imaging system 164 of FIGS. 1 – 10 or any of the other implementations disclosed herein. The order of execution of the blocks may be

changed, and/or some of the blocks described may be changed, eliminated, combined and/or subdivided into multiple blocks.

[00108] The process of FIG. 11 begins with the sample 165 being dispensed onto the first plate 202 of the substrate 400 (Block 1102). The sample 165 dispensed may also be referred to as a portion of the sample 165. The second plate 200 of the substrate 400 is positioned on the first plate 202 and the gap 204 is defined between the first plate 202 and the second plate 200 using a plurality of spacers 402 (Block 1104). The spacers 402 are ball bearings 404 having opposing flat surfaces 406, 408 in some implementations. The seal 414 is positioned around a perimeter of the first plate 202 and the second plate 204 and between the first plate 202 and the second plate 200 (Block 1106). Image data of the sample 165 is obtained (Block 1108) and a concentration of the sample 165 is determined using the image data (Block 1110). The imaging system 164 obtains image data of the sample 165 in some implementations and the imaging system 164 and/or the system 100 uses the image data to determine a concentration of the sample 165.

[00109] The process of FIG. 12 begins with the sample 165 being dispensed in an inlet 206, 703 of the channel 212, 412 of the substrate 162, 700 (Block 1202). The sample 165 dispensed may also be referred to as a portion of the sample 165. A fluid 706 is dispensed into the channel 212, 412 to separate the sample 165 and another sample 165 (Block 1204). The fluid 706 includes oil in some implementations. The fluid 706 may be dispensed into the channel 212 by dispensing the fluid into the second inlet 702 and/or the third inlet 704 of the channel 212. Image data of the sample 165 is obtained (Block 1206). The image data may be obtained through the window 506 of the substrate 162, 700. The window 506 may be an unmasked region and the masked region 502 may surround the unmasked region. A concentration of the sample 165 may be determined using the image data (Block 1208) and the sample 165 may be flowed out of the outlet 208 of the channel 212, 412 (Block 1210). Flowing the sample 165 out of the outlet 208 of the channel 212, 412 may include urging the sample 165 out of the outlet 208 of the channel 212, 412 using negative pressure and/or using the fluid 706.

[00110] FIG. 13 is a schematic implementation of a substrate 1300 and the imaging system 164 that can be used to implement the substrate 162 and the imaging system 164 of FIG. 1. The substrate 1300 may be implemented by a microfluidic card and/or may be made of a pair of plates. The substrate 1300 has a channel 1302 including an inlet 1304 and an outlet 1306, and a valve 1308 disposed between the inlet 1304 and the outlet 1306. The channel 1302 has a first portion 1310 between the valve 1308 and the inlet 1304 and a second portion 1312 between the valve 1308 and the outlet 1306. A portion of a sample 165 is received within the first portion 1310 of the channel 1302 of the substrate 1300 in

operation and the imaging system 165 obtains image data of the portion of the sample 165. The image data is used to determine a concentration of the portion of the sample 165.

[00111] The portion of the sample 165 is to flow from the first portion 1310, through the valve 1308, the second portion 1312, and the outlet 1306 after the image data of the portion of the sample 165 is obtained. The valve 1308 may be implemented by a mechanical valve such as an elastomer valve, a rotary face-sealing valve. The valve 1308 may be implemented by other mechanical valves, however. For example, the valve 1308 may be implemented by a rotary valve, a pinch valve, a flat valve, a solenoid valve, a check valve, and/or a piezo valve. The valve 1308 may be actuated to the open position if the valve 1308 is implemented by a mechanical valve to allow the portion of the sample 165 to flow from the first portion 1310, through the valve 1308, the second portion 1312, and the outlet 1306. The valve 1308 may alternatively be implemented by a virtual valve as further disclosed below.

[00112] A pump 1314 is also included that moves the sample 165 from the inlet 1304 to the outlet 106. The pump 1314 may be used to implement the pump 215 of FIG. 1. The pump 1314 has a plate 1316 including an axis of rotation 1318 and an actuator 1320 to rotate the plate 1316. The substrate 1300 is coupled to the plate 1316 and extends radially from the axis of rotation 1318.

[00113] A second substrate 1324 is shown coupled to the plate 1316 and extends radially from the axis of rotation 1318. The second substrate 1324 may be the same or similar to the substrate 1300. The plate 1316 has a first position 1326 and a second position 1328 and the substrate 1300 is shown positioned at the first position 1326 and the second substrate 1324 is shown positioned at the second position 1328. The first position 1326 is opposite the second position 1328. The second substrate 1324 may be a mirror image of the substrate 1300 on the plate 1316.

[00114] The pump 1314 includes an optical access area 1330. The optical access area 1330 allows the imaging system 164 to obtain the image data of the sample 165 within the channel 1302. The actuator 1320 may rotate the substrate 1300 and/or the second substrate 1324 to align the imaging system 164 with the corresponding substrate 1300, 1324 to allow the imaging data to be obtained.

[00115] The waste reservoir 214 is shown fluidly coupled to the outlet 1306. A waste spout 1331 is shown extending from the outlet 1306 into the waste reservoir 214. The waste reservoir 214 includes a vent 1332 in the implementation shown. The vent 1332 may include a porous frit 1334. The porous frit 1334 may be used to limit the escape of an aerosolized sample, for example. The waste reservoir 214 may be removable for draining and/or

cleaning. The waste reservoir 214 may, thus, be reusable. The waste reservoir 214 may alternatively be a disposable microfluidic card assembly as an example.

[00116] FIG. 14 is a top view of the substrate 1300 and the pump 1314 of FIG. 13. The valve 1308 is shown as a virtual valve 1336 in the implementation shown. The virtual valve 1336 is formed by a constriction 1338. The constriction 1338 reduces a width of the channel 1302. The first portion 1326 of the channel 1302 has a first width, the second portion 1328 of the channel 1302 has a second width, and the virtual valve 1336 has a third width. The third width being less than the first width and the second width. The virtual valve 1336 may be associated with a sharp expansion in the geometry of the channel 1302 preceded by a sharp constriction in the geometry of the channel 1302. The virtual valve 1336 may be patterned into the substrate 1300 or formed at a micro-to-macro junction between the substrate 1300 and/or the channel 1302 of the substrate 1300 and the waste spout 1331.

[00117] The channel 1302 may have a height of between about 200 micrometers and about 500 micrometers in some examples. The channel 1302 may have a different height, however. The channel 1302 may hold about 2 microliters to about 200 microliters as an example.

[00118] The substrate 1300 includes a mask 1340 in the implementation shown. The mask 1340 may be an opaque mask. The mask 1340 defines a window 1342 that allows the imaging system 164 to obtain image data of a portion of the sample 165, for example.

[00119] FIG. 15 is a detailed view of a portion of the substrate 1300 and the pump 1314 of FIG. 13. An inlet port 1344 is positioned at the inlet 1304 that funnels the portion of the sample 165 into the channel 1302 in the implementation shown. The inlet port 1344 includes a flow passage 1346. The flow passage 1346 is shown as a frustrum-shaped flow passage 1348. The flow passage 1346 may have a different shape, however. The flow passage 1346 may be cylindrical as an example.

[00120] The inlet port 1344 includes a first surface 1350 and a second surface 1352. The first surface 1350 is coupled to the substrate 1300. The frustrum-shaped flow passage 1348 has a base opening 1354 at the first surface 1350 and a top opening 1356 at the second surface 1352. The base opening 1354 has a perimeter and the inlet 1304 of the channel 1302 may be tangential to the base opening 1354 in some implementations. The base opening 1354 may be radially offset from the inlet 1304, for example.

[00121] FIG. 16 is a schematic implementation of a circular substrate 1400 that can be used to implement the substrate 162 and the pump 215 of FIG. 1. The circular substrate 1400 includes a plurality of channels 1302, where each channel 1302 has an inlet 1304 and an outlet 1306, and a valve 1308 disposed between the inlet 1304 and the outlet 1306. The

circular substrate 1400 may be implemented by a plastic disc and/or a circular wafer. The circular substrate 1400 includes an axis of rotation 1318, further comprising an actuator may be used to rotate the circular substrate 1400 about the axis of rotation 1318. The actuator may be a rotary actuator, for example. The channels 1302 extend radially from the axis of rotation 1318 in the implementation shown.

[00122] FIGS. 17 - 18 illustrate flowcharts for methods of implementing the examples disclosed herein. The order of execution of the blocks may be changed, and/or some of the blocks described may be changed, eliminated, combined and/or subdivided into multiple blocks.

[00123] The process of FIG. 17 begins with the substrate 1300, 1400 being rotated around an axis of rotation 1318 at a first rate to draw a portion of a sample 165 into a first portion 1310 of a channel 1302 of the substrate 1300, 1400 (Block 1502). The substrate 1300, 1400 includes the channel 1302, the inlet 1304, the outlet 1306 in fluid communication with the channel 1302, and the valve 1308 disposed between the inlet 1304 and the outlet 1306. The channel 1302 includes the first portion 1310 between the valve 1308 and the inlet 1304 and the second portion 1312 between the valve 1308 and the outlet 1306. The valve 1308 may include the virtual valve 1336. The virtual valve 1336 may include the constriction 1338.

[00124] The rotation of the substrate 1300, 1400 is stopped (Block 1504) and image data of the portion of the sample 165 is obtained (Block 1506). The image data may be used to determine a concentration of the portion of the sample 165, for example.

[00125] The substrate 1300, 1400 is rotated around the axis of rotation 1318 at a second rate to urge the portion of the sample 165 through the valve 1308 and into the second portion 1312 of the channel 1302 of the substrate 1300, 1400 and out of the outlet 1306 (Block 1508). The portion of the sample 165 is received in a waste reservoir 214 fluidly coupled to the outlet 1306 (Block 1510). The channel 1302 is rinsed by flowing a rinse fluid through the channel 1302 and between the inlet 1304 and the outlet 1306 (Block 1512).

[00126] The process of FIG. 18 begins by the substrate 1300, 1400 being rotated around an axis of rotation 1318 to draw a portion of a sample 165 into a first portion 1310 of a channel 1302 of the substrate 1300, 1400 (Block 1602). The substrate 1300, 1400, includes the channel 1302, the inlet 1304, the outlet 1306 in fluid communication with the channel 1302, and the valve 1308 disposed between the inlet 1304 and the outlet 1306. The channel 1302 includes the first portion 1310 between the valve 1308 and the inlet 1304 and the second portion 1312 between the valve 1308 and the outlet 1306. The rotation of the substrate 1300, 1400 is stopped (Block 1604).

[00127] Image data of the portion of the sample 165 is obtained (Block 1606). The image data may be used to determine a concentration of the portion of the sample 165. The valve 1308 is actuated to an open position (Block 1608) and the substrate 1300, 1400 is rotated around the axis of rotation 1318 to urge the portion of the sample 165 through the valve 1308 and into the second portion 1312 of the channel 1302 of the substrate 1300, 1400 and out of the outlet 1306 (Block 1610). The valve 1308 may be implemented by a mechanical valve in such an implementation. The channel 1302 is rinsed by flowing a rinse fluid through the channel 1302 and between the inlet 1304 and the outlet 1306 (Block 1612). The rinse fluid may be removed from the channel 1302 by the centrifugal force of rotating the substrate 1300, 1400.

[00128] The foregoing description is provided to enable a person skilled in the art to practice the various configurations described herein. While the subject technology has been particularly described with reference to the various figures and configurations, it should be understood that these are for illustration purposes only and should not be taken as limiting the scope of the subject technology.

[00129] As used herein, an element or step recited in the singular and proceeded with the word "a" or "an" should be understood as not excluding plural of said elements or steps, unless such exclusion is explicitly stated. Furthermore, references to "one implementation" are not intended to be interpreted as excluding the existence of additional implementations that also incorporate the recited features. Moreover, unless explicitly stated to the contrary, implementations "comprising," "including," or "having" an element or a plurality of elements having a particular property may include additional elements whether or not they have that property. Moreover, the terms "comprising," "including," "having," or the like are interchangeably used herein.

[00130] The terms "substantially," "approximately," and "about" used throughout this Specification are used to describe and account for small fluctuations, such as due to variations in processing. For example, they can refer to less than or equal to $\pm 5\%$, such as less than or equal to $\pm 2\%$, such as less than or equal to $\pm 1\%$, such as less than or equal to $\pm 0.5\%$, such as less than or equal to $\pm 0.2\%$, such as less than or equal to $\pm 0.1\%$, such as less than or equal to $\pm 0.05\%$. In one example, these terms include situation where there is no variation – 0%.

[00131] There may be many other ways to implement the subject technology. Various functions and elements described herein may be partitioned differently from those shown without departing from the scope of the subject technology. Various modifications to these implementations may be readily apparent to those skilled in the art, and generic principles

defined herein may be applied to other implementations. Thus, many changes and modifications may be made to the subject technology, by one having ordinary skill in the art, without departing from the scope of the subject technology. For instance, different numbers of a given module or unit may be employed, a different type or types of a given module or unit may be employed, a given module or unit may be added, or a given module or unit may be omitted.

[00132] Underlined and/or italicized headings and subheadings are used for convenience only, do not limit the subject technology, and are not referred to in connection with the interpretation of the description of the subject technology. All structural and functional equivalents to the elements of the various implementations described throughout this disclosure that are known or later come to be known to those of ordinary skill in the art are expressly incorporated herein by reference and intended to be encompassed by the subject technology. Moreover, nothing disclosed herein is intended to be dedicated to the public regardless of whether such disclosure is explicitly recited in the above description.

[00133] It should be appreciated that all combinations of the foregoing concepts and additional concepts discussed in greater detail below (provided such concepts are not mutually inconsistent) are contemplated as being part of the subject matter disclosed herein. In particular, all combinations of claimed subject matter appearing at the end of this disclosure are contemplated as being part of the subject matter disclosed herein.

CLAIMS

What is claimed is:

1. An apparatus, comprising:
 - a substrate comprising a pair of plates and a plurality of spacers positioned between the plates to define a gap between the pair of plates; and
 - an imaging system,wherein a portion of a sample is to be received within the gap of the substrate and the imaging system is to obtain image data of the portion of the sample, the image data to be used to determine a concentration of the portion of the sample.
2. The apparatus of claim 1, wherein the spacers comprise ball bearings having opposing flat surfaces.
3. The apparatus of any one of the preceding claims, wherein the plurality of spacers comprises three spacers.
4. The apparatus of any one of the preceding claims, wherein the gap is about 500 micrometers.
5. The apparatus of any of the preceding claims, wherein a channel is defined between the pair of plates.
6. The apparatus of claim 5, wherein the substrate further comprises a seal positioned between the pair of plates and defines the channel.
7. The apparatus of claim 6, wherein the seal is positioned around a perimeter of the pair of plates.
8. The apparatus of any one of the preceding claims, wherein the substrate comprises a mask.
9. The apparatus of claim 8, wherein the mask is an opaque mask.
10. The apparatus of any one of the preceding claims, wherein the substrate comprises an inlet and an outlet in fluid communication with the gap.
11. The apparatus of any one of the preceding claims, wherein the substrate comprises a plurality of channels.
12. The apparatus of any one of the preceding claims, wherein the substrate comprises a first inlet, a second inlet, a third inlet, and an outlet in fluid communication with the gap.
13. A method, comprising:
 - dispensing a sample onto a first plate of a substrate;
 - positioning a second plate of the substrate on the first plate and defining a gap between the first plate and the second plate using a plurality of spacers;
 - obtaining image data of the sample; and
 - determining a concentration of the sample using the image data.

14. The method of claim 13, wherein the spacers comprise ball bearings having opposing flat surfaces.
15. The method of any one of claims 13 – 14, wherein the plurality of spacers comprises three spacers.
16. The method of any one of claims 13 – 15, further comprising positioning a seal around a perimeter of the first plate and the second plate.
17. A method, comprising:
 - dispensing a sample in an inlet of a channel of a substrate;
 - obtaining image data of the sample;
 - determining a concentration of the sample using the image data; and
 - flowing the sample out of an outlet of the channel.
18. The method of claim 17, wherein obtaining the image data comprises obtaining the image data through a window of the substrate.
19. The method of claim 18, wherein the window comprises an unmasked region and wherein a masked region may surround the unmasked region.
20. The method of any one of claims 17 – 19, further comprising dispensing a fluid into the channel to separate the sample and another sample.
21. The method of claim 20, wherein the fluid comprises oil.
22. The method of any one of claims 20 – 21, wherein dispensing the fluid into the channel comprises dispensing the fluid into a second inlet of the channel.
23. The method of any one of claims 17 – 22, wherein flowing the sample out of the outlet of the channel comprises urging the sample out of the outlet of the channel using negative pressure.
24. The method of any one of claims 17 – 22, wherein flowing the sample out of the outlet of the channel comprises urging the sample out of the outlet of the channel using a fluid.
25. An apparatus, comprising:
 - a substrate, comprising:
 - a channel including an inlet and an outlet; and
 - a valve disposed between the inlet and the outlet, wherein the channel comprises a first portion between the valve and the inlet and a second portion between the valve and the outlet; and
 - an imaging system,
 - wherein a portion of a sample is to be received within the first portion of the channel of the substrate and the imaging system is to obtain image data of the portion of the sample, the image data to be used to determine a concentration of the portion of the sample.

26. The apparatus of claim 25, further comprising a pump to move the sample from the inlet to the outlet.
27. The apparatus of claim 26, wherein the pump comprises a plate comprising an axis of rotation and an actuator to rotate the plate, the substrate coupled to the plate and extending radially from the axis of rotation.
28. The apparatus of claim 27, further comprising a second substrate coupled to the plate and extending radially from the axis of rotation.
29. The apparatus of claim 28, wherein the plate comprises a first position and a second position, the substrate positioned at the first position and the second substrate positioned at the second position, the first position opposite the second position.
30. The apparatus of any one of claims 28 – 29, wherein second substrate comprising a mirror image of the substrate on the plate.
31. The apparatus of any one of claims 26 - 31, wherein the pump comprises an optical access area.
32. The apparatus of any one of claims 25 – 31, further comprising a waste reservoir fluidly coupled to the outlet.
33. The apparatus of claim 32, wherein the waste reservoir comprises a vent.
34. The apparatus of claim 33, wherein the vent comprises a porous frit.
35. The apparatus of claim 32, wherein the waste reservoir comprises a disposable microfluidic card assembly.
36. The apparatus of any one of claims 25 – 32, wherein the valve comprises a virtual valve.
37. The apparatus of claim 36, wherein the virtual valve comprises a constriction.
38. An apparatus, comprising:
 - a substrate, comprising:
 - a channel including an inlet and an outlet; and
 - a valve disposed between the inlet and the outlet, wherein the channel comprises a first portion between the valve and the inlet and a second portion between the valve the outlet,
 - wherein a portion of a sample is to be received within the first portion of the channel of the substrate and an imaging system is to obtain image data of the portion of the sample, the image data to be used to determine a concentration of the portion of the sample.
39. The apparatus of claim 38, wherein the portion of the sample is to flow from the first portion, through the valve, the second portion, and the outlet after the image data of the portion of the sample is obtained.

40. The apparatus of any one of claims 38 – 39, wherein the valve comprises a virtual valve.
41. The apparatus of claim 40, wherein the virtual valve comprises a constriction.
42. The apparatus of any one of claims 38 – 41, wherein the first portion of the channel has a first width, the second portion of the channel has a second width, and the virtual valve has a third width, the third width less than the first width and the second width.
43. The apparatus of any one of claims 38 – 42, wherein the channel comprises a height of between about 200 micrometers and about 500 micrometers.
44. The apparatus of anyone of claims 38 – 43, wherein the substrate comprises a mask.
45. The apparatus of claim 44, wherein the mask is an opaque mask.
46. The apparatus of any one of claims 38 – 45, wherein the substrate comprises a microfluidic card.
47. The apparatus of any one of claims 38, 39, 43 – 46, wherein the valve comprises an elastomer valve or a rotary face-sealing valve.
48. The apparatus of anyone of claims 38 – 47, further comprising an inlet port at the inlet that is to funnel the portion of the sample into the channel.
49. The apparatus of claim 48, wherein the inlet port comprises a flow passage comprising a frustrum-shaped flow passage.
50. The apparatus of claim 49, wherein the inlet port comprises a first surface and a second surface, the first surface coupled to the substrate, the frustrum-shaped flow passage comprises a base opening at the first surface and a top opening at the second surface, the base opening having a perimeter, the inlet being tangential to the base opening.
51. An apparatus, comprising:
 - a circular substrate comprising a plurality of channels, each channel comprising:
 - an inlet;
 - an outlet; and
 - a valve disposed between the inlet and the outlet, wherein the channel comprises a first portion between the valve and the inlet and a second portion between the valve the outlet.
52. The apparatus of claim 51, wherein the circular substrate comprises a plastic disc.
53. The apparatus of claim 51, wherein the circular substrate comprises a circular wafer.
54. The apparatus of any one of claims 51 - 53, wherein the circular substrate comprises an axis of rotation, further comprising an actuator to rotate the circular substrate about the axis of rotation, the channels extending radially from the axis of rotation.
55. A method, comprising:
 - rotating a substrate around an axis of rotation at a first rate to draw a portion of a sample into a first portion of a channel of the substrate, the substrate,

comprising: the channel; an inlet; an outlet in fluid communication with the channel; and a valve disposed between the inlet and the outlet, wherein the channel comprises the first portion between the valve and the inlet and a second portion between the valve and the outlet;

stopping the rotation of the substrate;

obtaining image data of the portion of the sample, the image data to be used to determine a concentration of the portion of the sample;

rotating the substrate around the axis of rotation at a second rate to urge the portion of the sample through the valve and into the second portion of the channel of the substrate and out of the outlet.

56. The method of claim 55, further comprising receiving the portion of the sample in a waste reservoir fluidly coupled to the outlet.

57. The method of any one of claims 55 – 56, further comprising rinsing the channel by flowing a rinse fluid through the channel and between the inlet and the outlet.

58. The method of any one of claims 55 – 57, wherein the valve comprises a virtual valve.

59. The method of claim 58, wherein the virtual valve comprises a constriction.

60. A method, comprising:

rotating a substrate around an axis of rotation to draw a portion of a sample into a first portion of a channel of the substrate, the substrate, comprising: the channel; an inlet; an outlet in fluid communication with the channel; and a valve disposed between the inlet and the outlet, wherein the channel comprises the first portion between the valve and the inlet and a second portion between the valve and the outlet;

stopping the rotation of the substrate;

obtaining image data of the portion of the sample, the image data to be used to determine a concentration of the portion of the sample;

actuating the valve to an open position; and

rotating the substrate around the axis of rotation to urge the portion of the sample through the valve and into the second portion of the channel of the substrate and out of the outlet.

61. The method of claim 60, further comprising rinsing the channel by flowing a rinse fluid through the channel and between the inlet and the outlet.

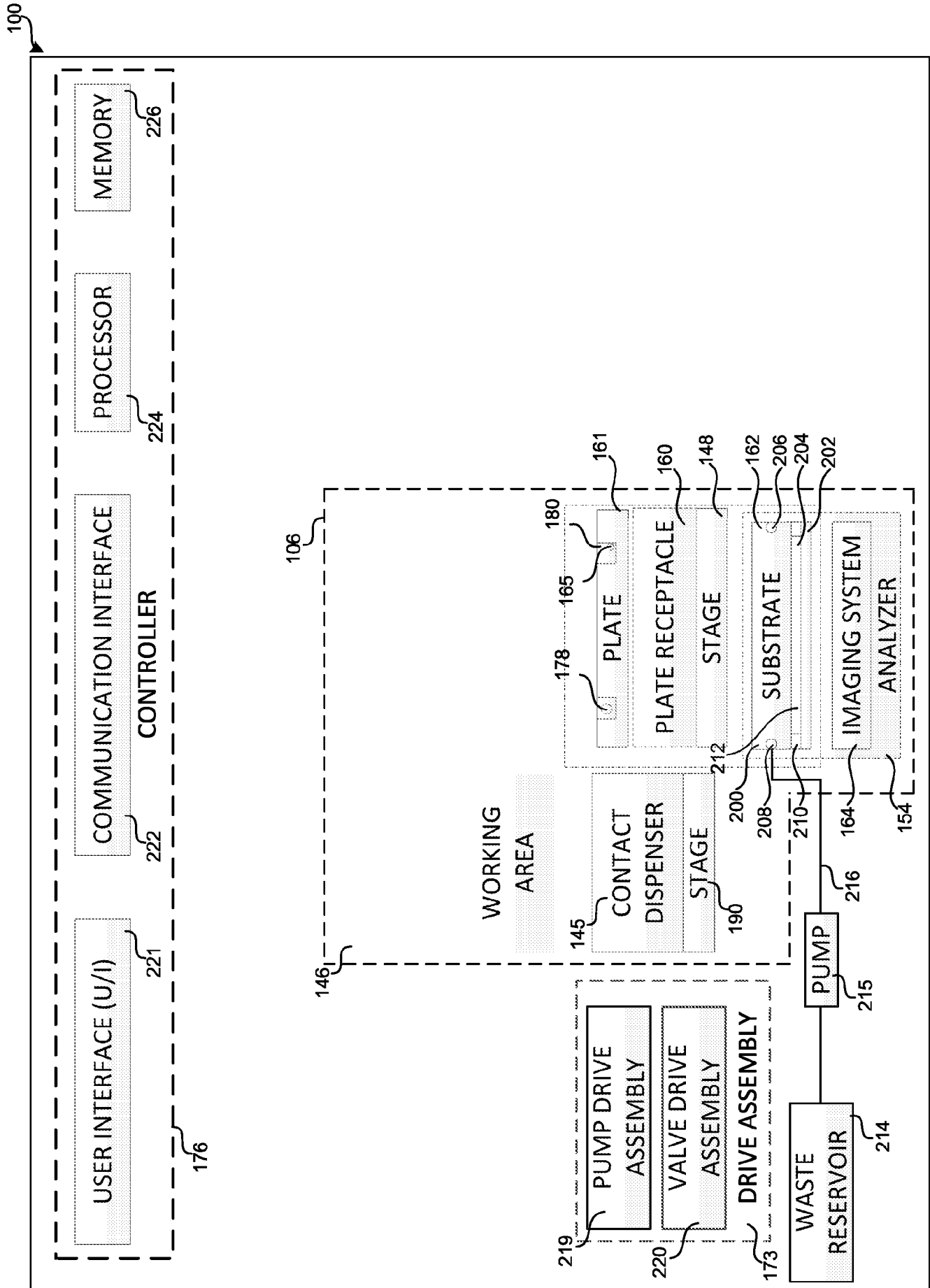


FIG. 1

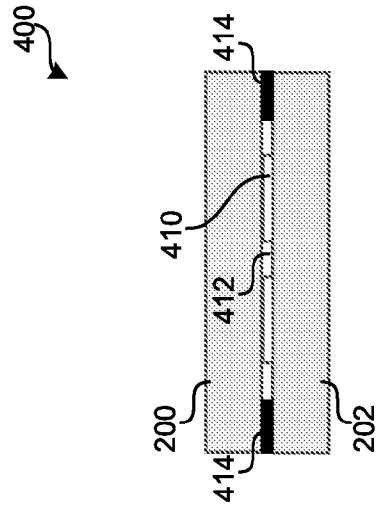
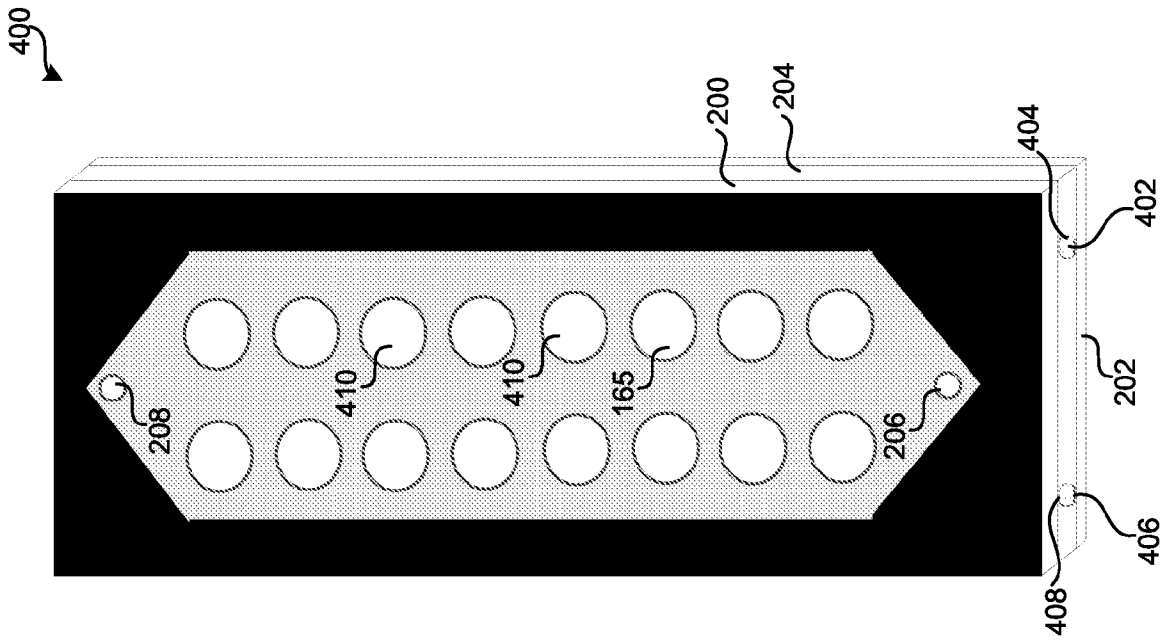


FIG. 3

FIG. 2

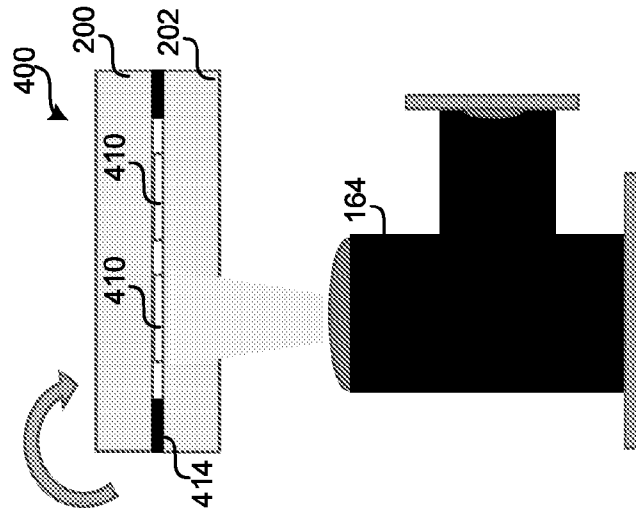


FIG. 5

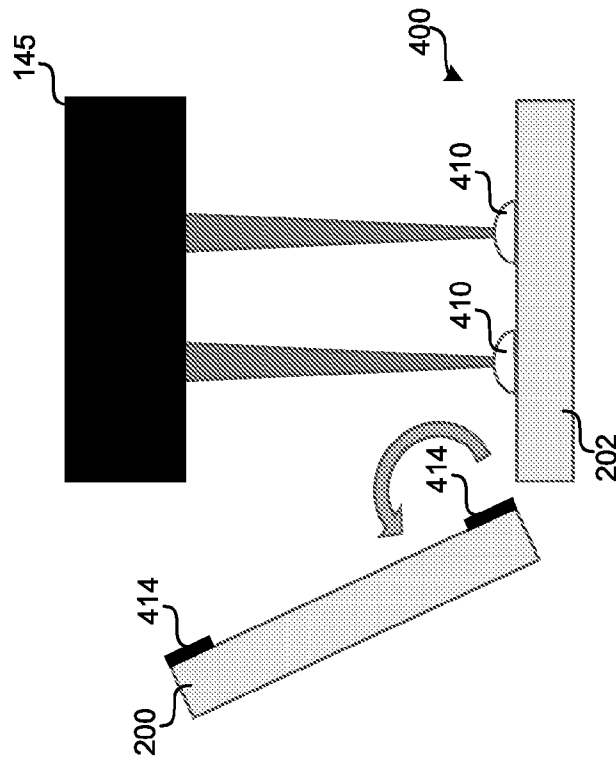


FIG. 4

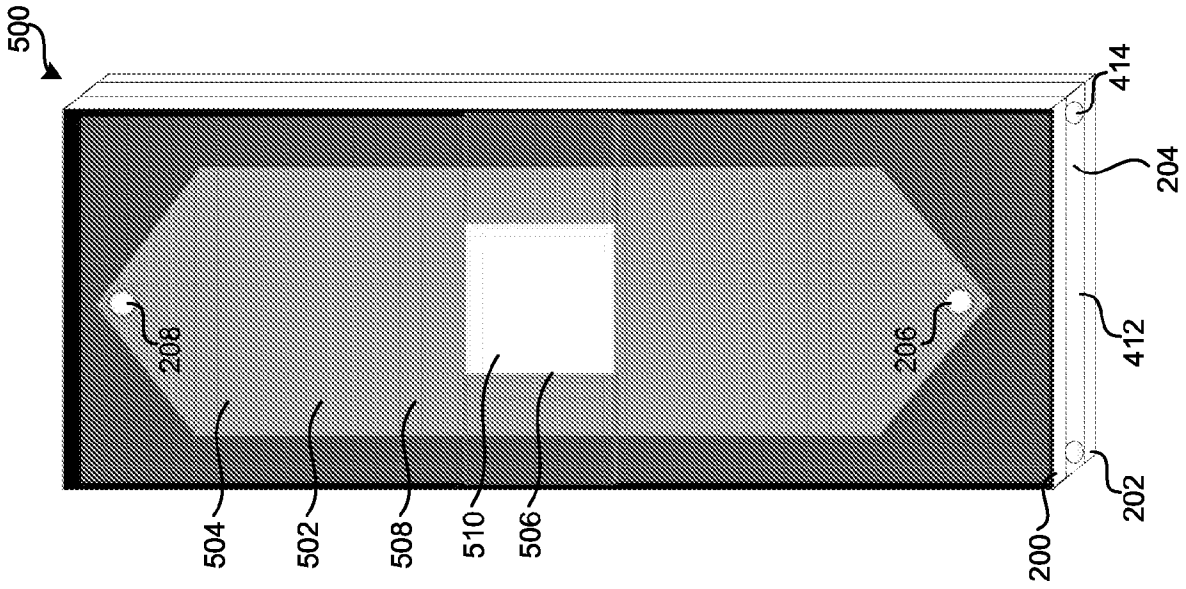


FIG. 6

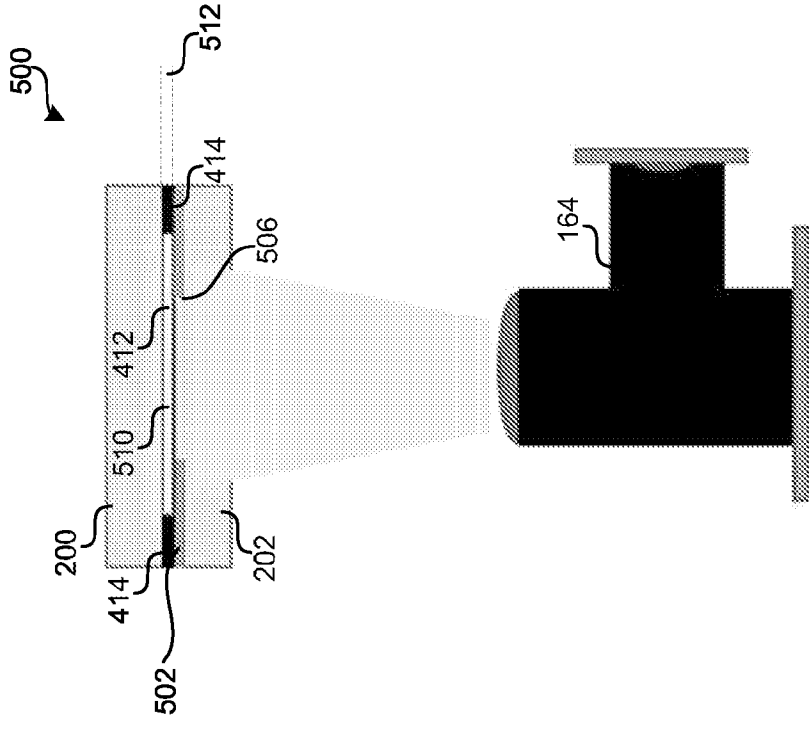


FIG. 7

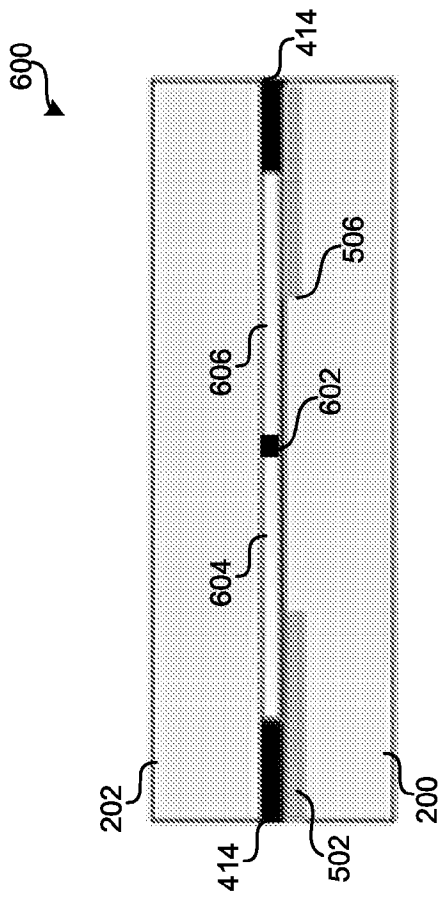


FIG. 8

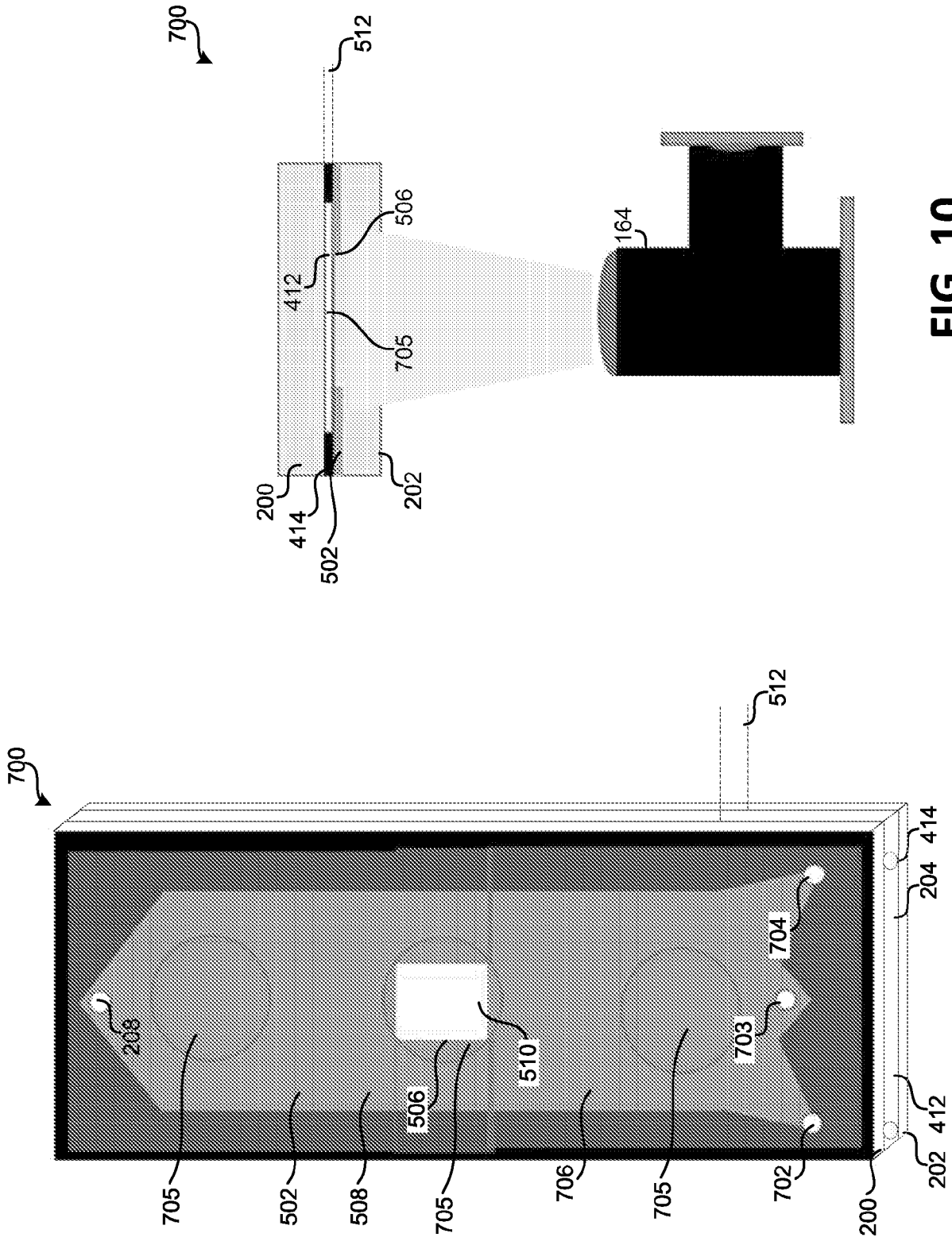


FIG. 10

FIG. 9

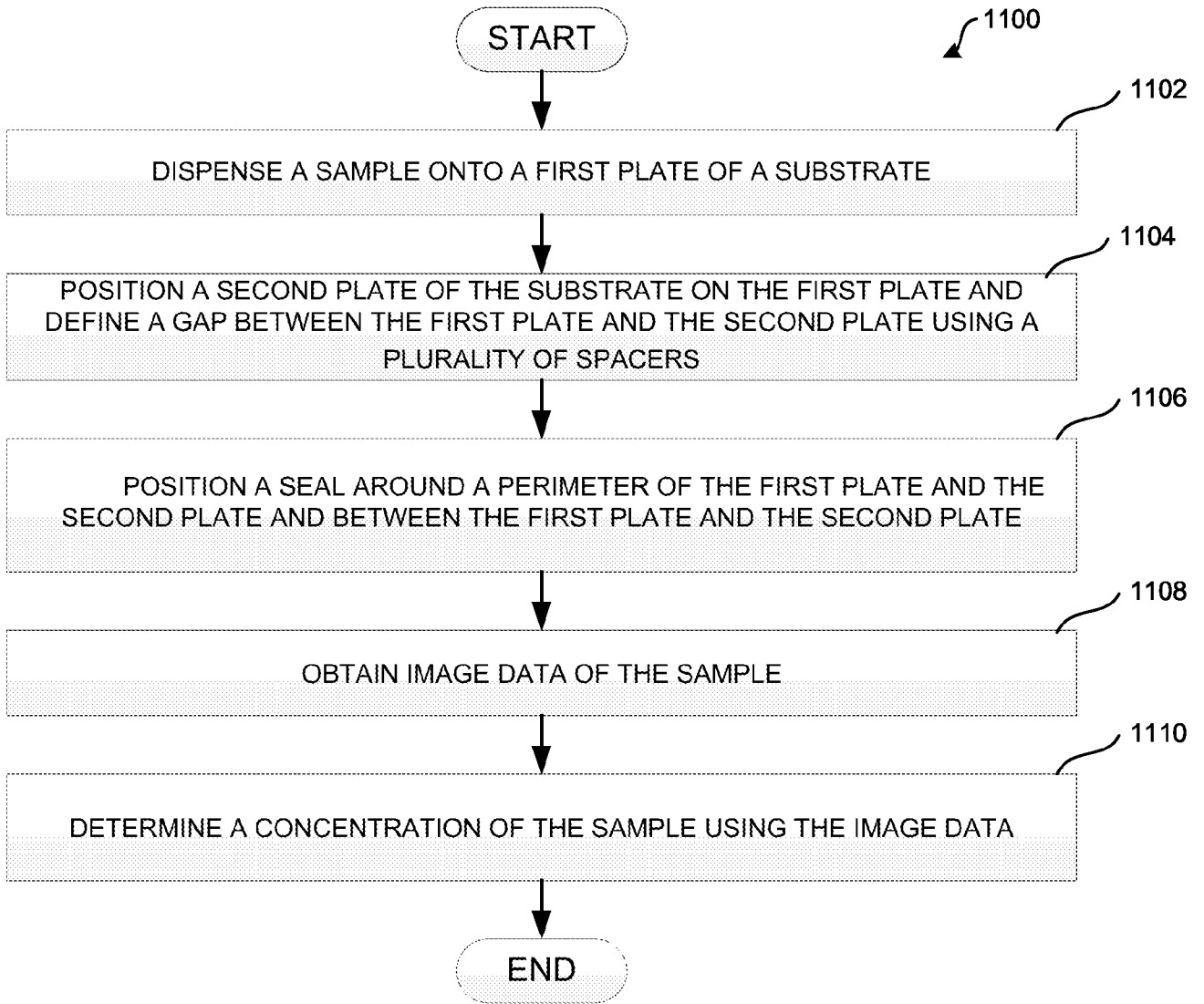
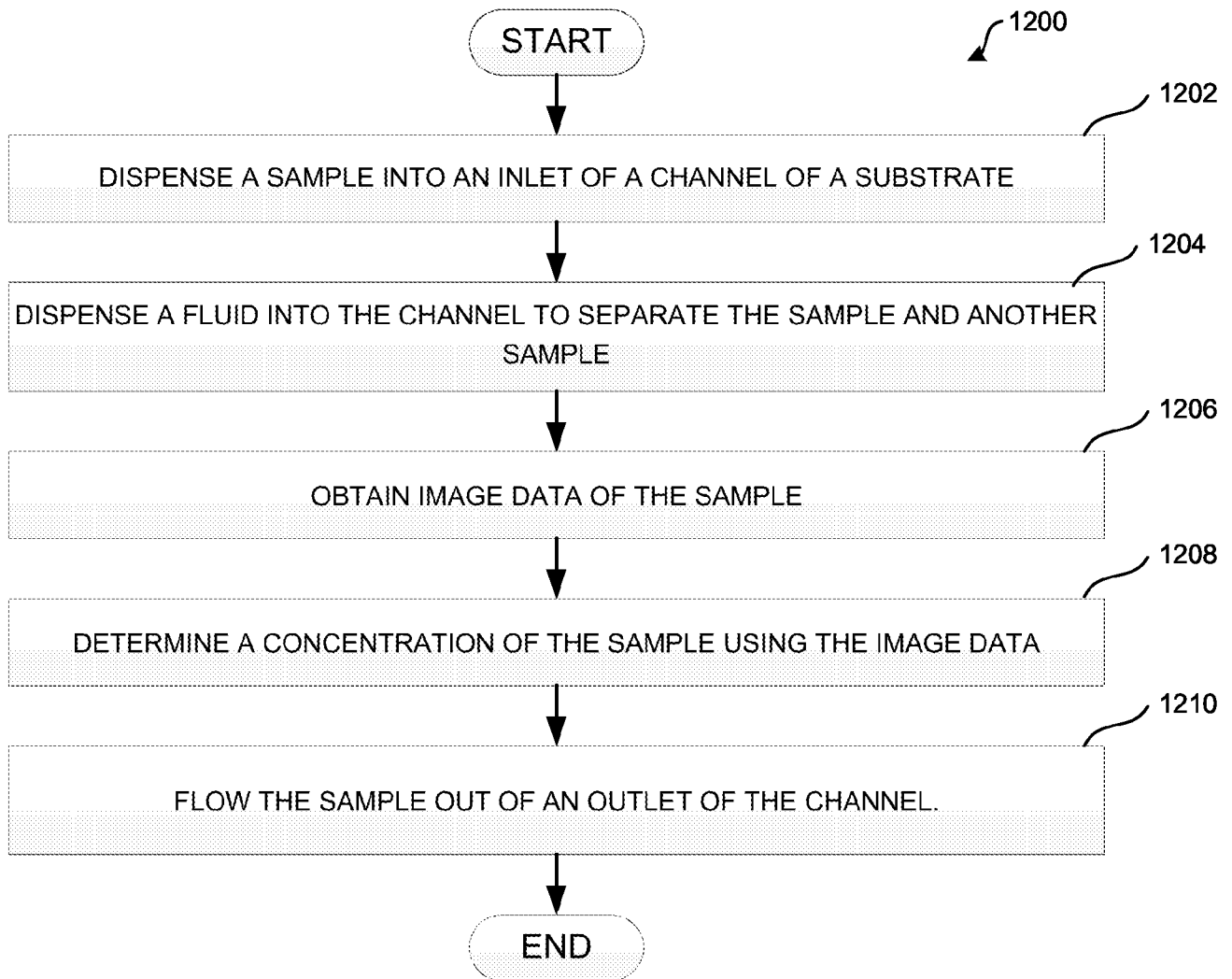


FIG. 11

**FIG. 12**

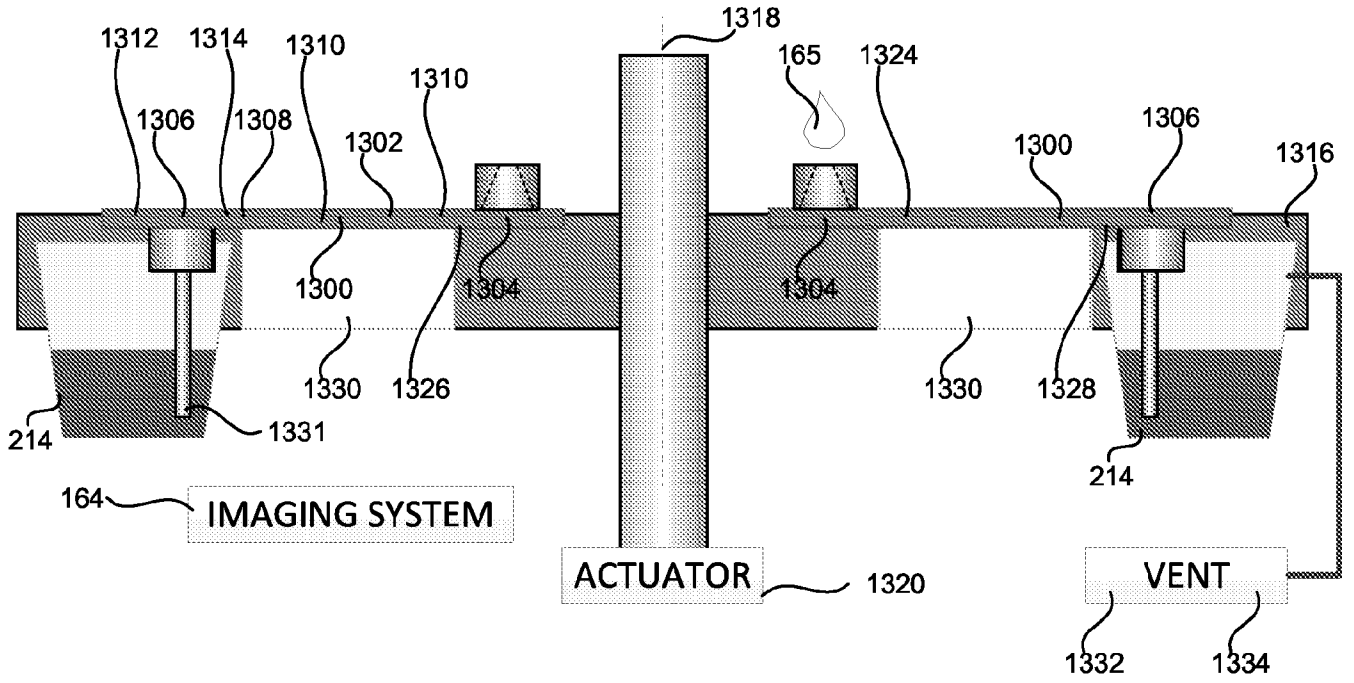


FIG. 13

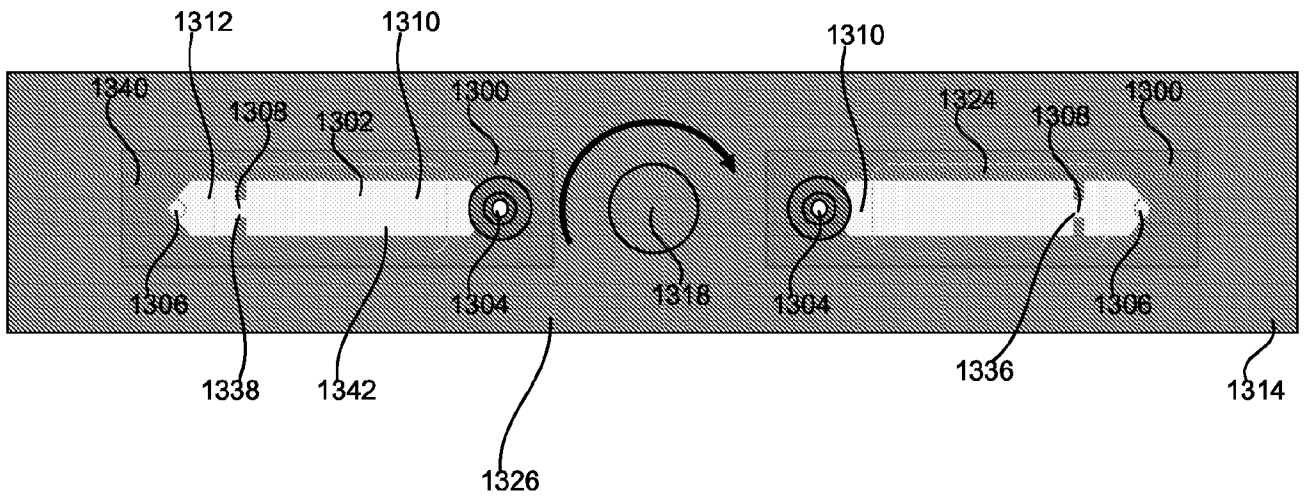


FIG. 14

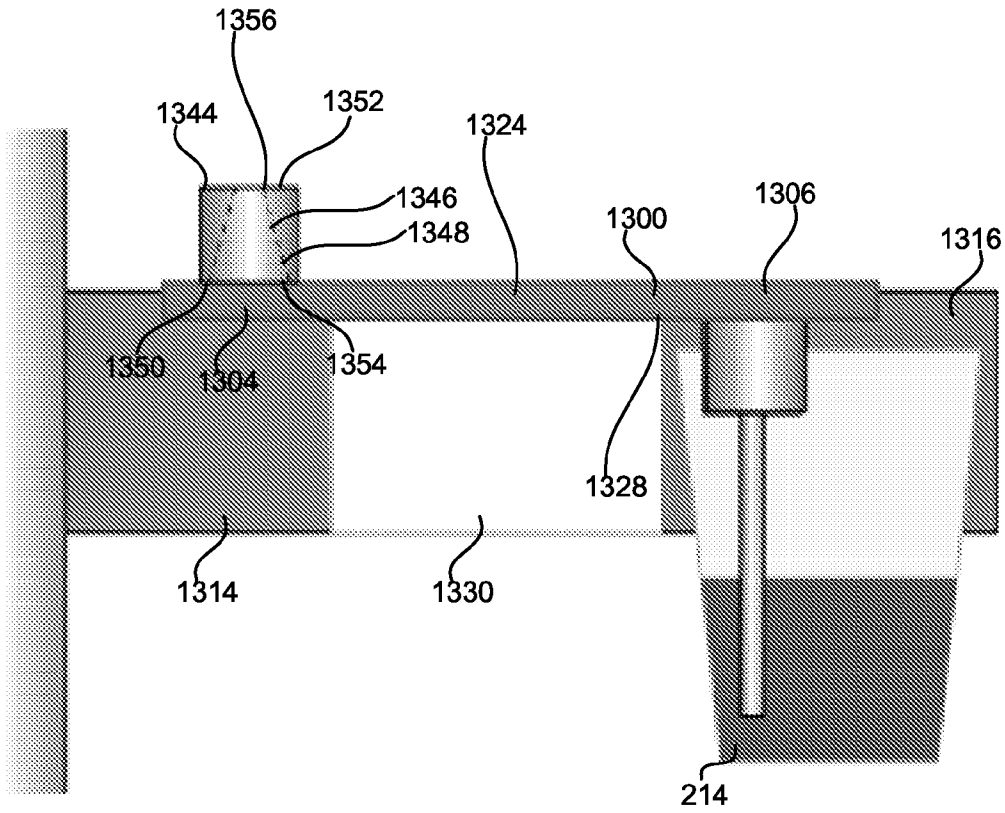


FIG. 15

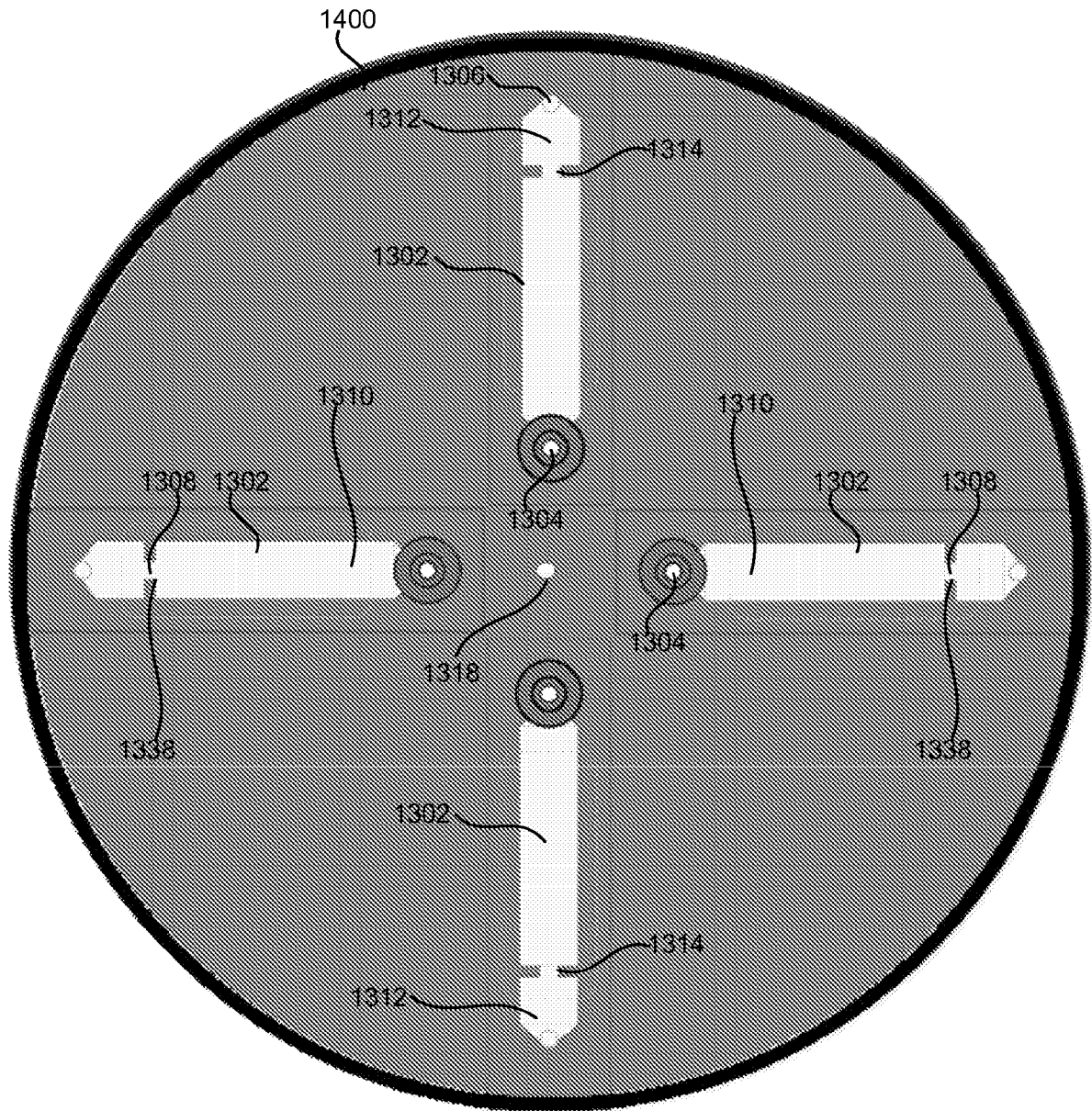


FIG. 16

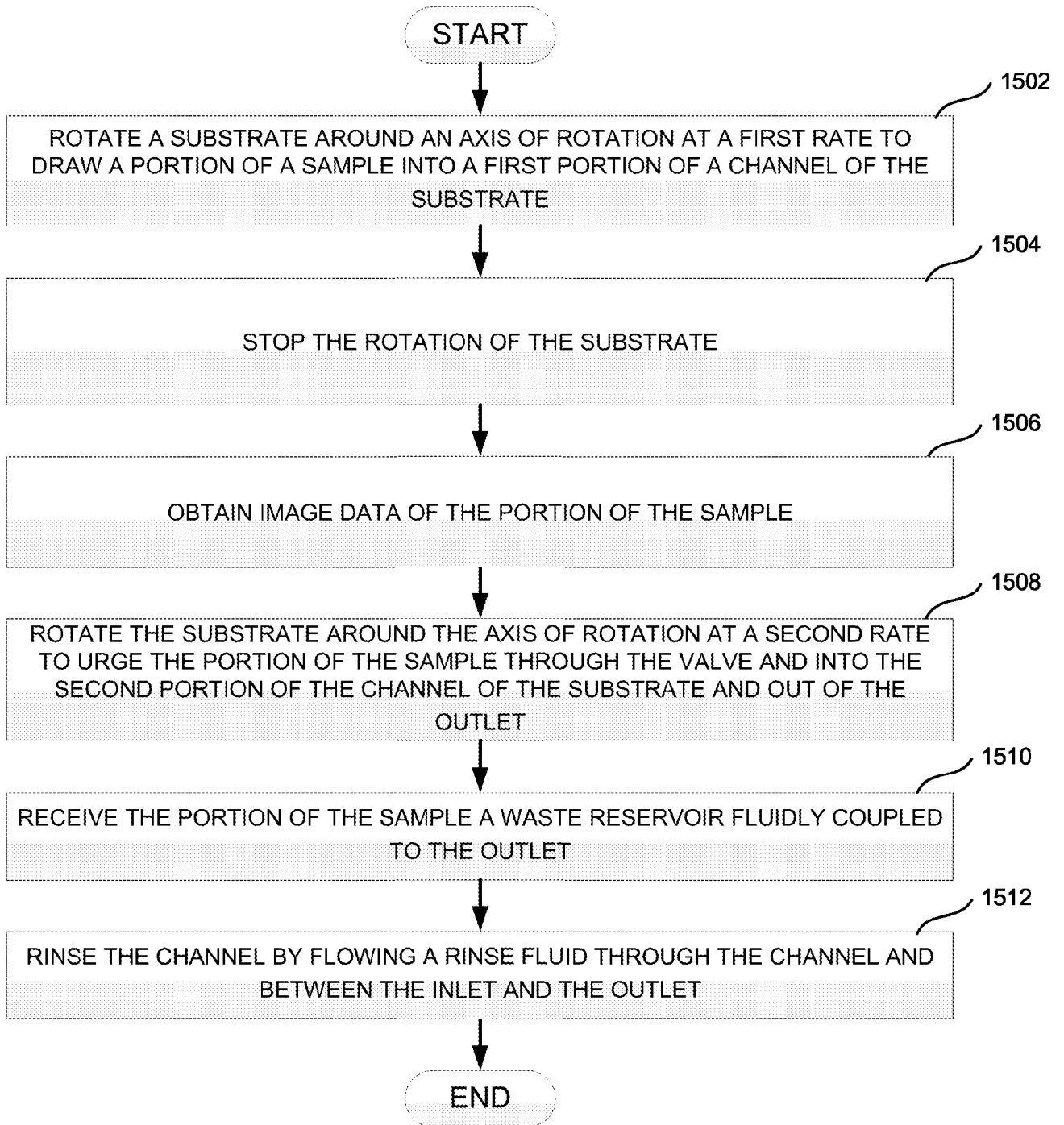


FIG. 17

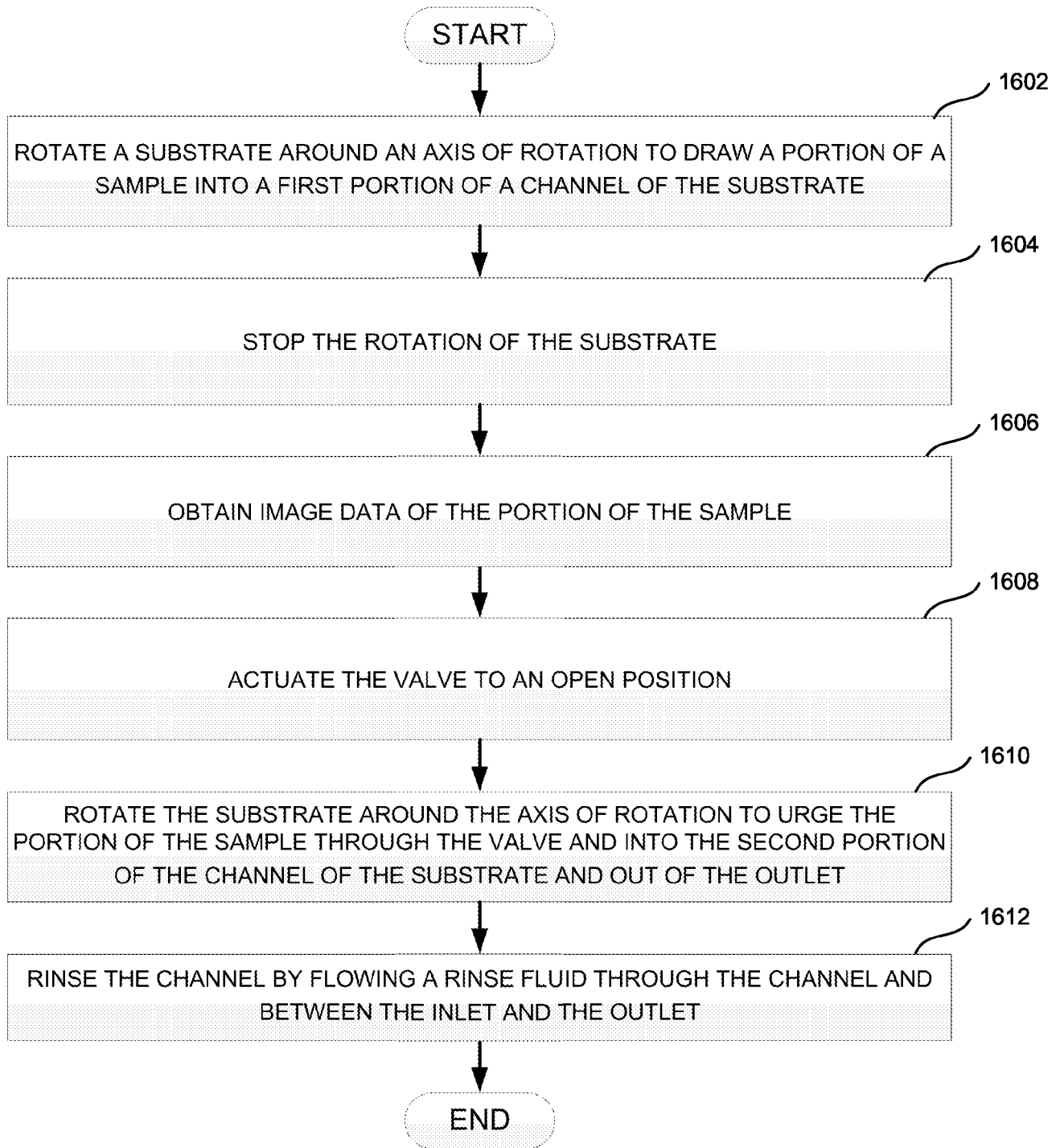


FIG. 18

INTERNATIONAL SEARCH REPORT

International application No.

PCT/US2023/026330

A. CLASSIFICATION OF SUBJECT MATTER G01N 35/00(2006.01)i; G01N 35/10(2006.01)i		
According to International Patent Classification (IPC) or to both national classification and IPC		
B. FIELDS SEARCHED		
Minimum documentation searched (classification system followed by classification symbols) G01N 35/00(2006.01); B01F 13/00(2006.01); B01L 3/00(2006.01); B64F 5/60(2017.01); G01N 15/14(2006.01); G01N 21/84(2006.01); G02B 21/36(2006.01); H04N 5/225(2006.01)		
Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched Korean utility models and applications for utility models Japanese utility models and applications for utility models		
Electronic data base consulted during the international search (name of data base and, where practicable, search terms used) eKOMPASS(KIPO internal) & Keywords: substrate, plate, gap, spacer, imaging system, analysis, quantification, actuator, rotation		
C. DOCUMENTS CONSIDERED TO BE RELEVANT		
Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X A	US 2016-0109693 A1 (ILLUMINA, INC.) 21 April 2016 (2016-04-21) See paragraphs [0046], [0050], [0065], [0074], [0079]-[0080]; claims 24-25, 27-30; figures 5A, 10A-10B.	1-3,13-15,17-21, 25-26,38-41,51-53 27-30,54-57,60-61
X	WO 2019-195818 A1 (REDBUD LABS) 10 October 2019 (2019-10-10) See paragraphs [0053]-[0054], [0077]; claims 16-18; figures 5-7.	1-3,13-15,17-21, 25-26,38-41,51-53
X	US 2021-0162414 A1 (IMEC VZW) 03 June 2021 (2021-06-03) See paragraphs [0087], [0104]-[0108], [0110], [0115]-[0117]; claims 1, 7-9, 15-19; figure 2.	1-3,13-15,17-21
X	US 2019-0111424 A1 (ESSENIX CORPORATION) 18 April 2019 (2019-04-18) See claims 1-2, 20, 50, 58; figure 2.	1-3,13-15
<input checked="" type="checkbox"/> Further documents are listed in the continuation of Box C. <input checked="" type="checkbox"/> See patent family annex.		
* Special categories of cited documents: "A" document defining the general state of the art which is not considered to be of particular relevance "D" document cited by the applicant in the international application "E" earlier application or patent but published on or after the international filing date "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) "O" document referring to an oral disclosure, use, exhibition or other means "P" document published prior to the international filing date but later than the priority date claimed "T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art "&" document member of the same patent family		
Date of the actual completion of the international search 23 October 2023		Date of mailing of the international search report 23 October 2023
Name and mailing address of the ISA/KR Korean Intellectual Property Office 189 Cheongsa-ro, Seo-gu, Daejeon 35208, Republic of Korea Facsimile No. +82-42-481-8578		Authorized officer HEO, Joo Hyung Telephone No. +82-42-481-5373

INTERNATIONAL SEARCH REPORT

International application No.

PCT/US2023/026330

C. DOCUMENTS CONSIDERED TO BE RELEVANT		
Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	CN 210175151 U (MICROJET TECHNOLOGY CO., LTD.) 24 March 2020 (2020-03-24) See the whole document.	1-3,13-15,17-21,25-30,38-41,51-57,60-61

Box No. II Observations where certain claims were found unsearchable (Continuation of item 2 of first sheet)

This international search report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:

1. Claims Nos.:
because they relate to subject matter not required to be searched by this Authority, namely:

2. Claims Nos.: **6-7,9,33-35,37,45,49-50,59**
because they relate to parts of the international application that do not comply with the prescribed requirements to such an extent that no meaningful international search can be carried out, specifically:

Claims 6-7, 9, 33-35, 37, 45, 49-50, 59 refer to unsearchable claims which do not comply with PCT Rule 6.4(a).

3. Claims Nos.: **4-5,8,10-12,16,22-24,31-32,36,42-44,46-48,58**
because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).

INTERNATIONAL SEARCH REPORT
Information on patent family members

International application No.

PCT/US2023/026330

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